

UNITED STATES INTERNATIONAL TRADE COMMISSION

Washington, D.C.

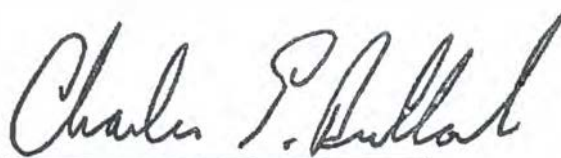
In the Matter of CERTAIN SEMICONDUCTOR LITHOGRAPHY SYSTEMS AND COMPONENTS THEREOF	Inv. No. 337-TA-1137
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NOTICE TO THE PARTIES

(October 11, 2018)

Notice is hereby given that the above-captioned investigation under section 337 of the
Tariff Act of 1930, as amended, 19 U.S.C. § 1337, is assigned to Administrative Law Judge
Dee Lord.

SO ORDERED.



Charles E. Bullock
Chief Administrative Law Judge

PUBLIC CERTIFICATE OF SERVICE

I, Lisa R. Barton, hereby certify that the attached **NOTICE OF ASSIGNMENT OF ALJ** has been served upon the following parties as indicated, on **October 11, 2018**.



Lisa R. Barton, Secretary
U.S. International Trade Commission
500 E Street, SW, Room 112
Washington, DC 20436

**On Behalf of Complainants ASML Netherlands B. V., ASML
US, L.P., ASML US, LLC:**

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1000 Maine Avenue, SW, Suite 1000
Washington, D.C. 20024

- Via Hand Delivery
- Via Express Delivery
- Via First Class Mail
- Other: _____

Respondents:

Nikon Corporation
Shinagawa Intercity Tower C,
2-15-3, Konan, Minato-ku
Tokyo 108-6290, Japan

- Via Hand Delivery
- Via Express Delivery
- Via First Class Mail
- Other: _____

Nikon Precision Inc.
1399 Shoreway Road
Belmont, CA 94002-4107

- Via Hand Delivery
- Via Express Delivery
- Via First Class Mail
- Other: _____

Nikon Research Corporation of America
1399 Shoreway Road
Belmont, CA 94002-4107

- Via Hand Delivery
- Via Express Delivery
- Via First Class Mail
- Other: _____